



JOURNAL OF EMERGING TECHNOLOGIES AND INNOVATIVE RESEARCH (JETIR)

An International Scholarly Open Access, Peer-reviewed, Refereed Journal

Ref No : JETIR / Vol 6 / Issue 5 / 045

Confirmation Letter

To,
D. R. Mahamne
Published in : Volume 6 | Issue 5 | 2019-05-01



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

About JETIR : An International Scholarly Open Access Journal, Peer-Reviewed, Refereed Journal Impact Factor Calculate by Google Scholar and Semantic Scholar | AI-Powered Research Tool, Multidisciplinary, Monthly, Multilanguage Journal Indexing in All Major Database & Metadata, Citation Generator, Impact Factor: 7.95, ISSN: 2349-5162

UGC Approval : UGC and ISSN Approved - UGC Approved Journal No: 63975 | Link: <https://www.ugc.ac.in/journallist/subjectwisejournallist.aspx?tid=MjM0OTUxNjI=&&did=U2VhcmNoIGJ5IEITU04=>

Registration ID : JETIR 204655

Paper ID : JETIRCP06045

Title of Paper : Study of ZnO Thin Films Prepared by Chemical Bath Deposition at Varying Temperatures

Impact Factor : 7.95 (Calculate by Google Scholar)

DOI :

Published in : Volume 6 | Issue 5 | 2019-05-01

Publication Date: 2019-05-01

Page No : 243-245

Published URL : <http://www.jetir.org/view?paper=JETIRCP06045>

Authors : D. R. Mahamne, M. D. Shinde, S. S. Jagtap, G. R. Pansare, K. D. Diwate

Thank you very much for publishing your article in JETIR. We would appreciate if you continue your support and keep sharing your knowledge by writing for our journal JETIR.

Editor In Chief

International Journal of Emerging Technologies and Innovative Research
(ISSN: 2349-5162)



www.jetir.org | editor@jetir.org | Impact Factor: 7.95 (Calculate by Google Scholar)